INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 7, 2026

IGI Report Number	LG800648607
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	FREEFORM FACETED
Measurements	7.71 X 6.12 X 3.63 MM

GRADING RESULTS

Carat Weight	1.31 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	VERY GOOD

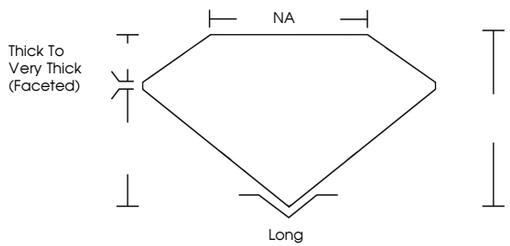
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG800648607

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG800648607
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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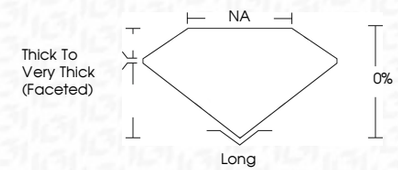

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IGI

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7.71 X 6.12 X 3.63 MM

Carat Weight	1.31 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	VERY GOOD
Depth	0%
Table	NA
Girdle	Thick To Very Thick (Faceted)
Culet	Long
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG800648607

Comments:
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Type IIa